

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of : Takashi TAKAHASHI

Serial No. : 09/408,437

Group Art Unit: 2753

Date Filed : September 29, 1999

Examiner:

For : SEMICONDUCTOR DEVICE WITH SATURABLE ABSORBING LAYER

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1185 Avenue of the Americas
New York, N.Y. 10036

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to Applicant's duty of disclosure, the information listed in the attached form PTO-1449 is brought to the attention of the Examiner. Copies of the information identified herein are also provided. A copy of Japanese document 9-331098 was not available.

It is respectfully requested that the information cited in annexed Form PTO-1449 be considered by the Examiner in connection with the above-identified patent application, and that such art be made of record in said application.

I hereby certify that this paper is being deposited this date with the U.S. Postal Service as first class mail addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Richard F. Jaworski Feb. 10, 2000

Richard F. Jaworski
Reg. No. 33,515

Date

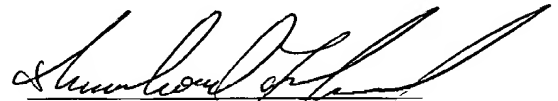
The citation of the listed items is not a representation that they constitute a complete or exhaustive listing of the relevant art or that these items are prior art. The items listed are submitted in good faith, but are not intended to substitute for the Examiner's search. It is hoped, however, that in addition to apprising the Examiner of the particular items, they will assist in identifying fields of search and in making as full and complete a search as possible.

The filing of this Information Disclosure Statement is not an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

The Office is hereby authorized to charge any additional fees which may be required for consideration of this Information Disclosure Statement and to credit any overpayment to our Deposit Account No. 03-3125.

Early and favorable consideration of the case is respectfully requested.

Respectfully submitted,



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